

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	261	(118/50.1) and (heat\$3 with (element filament) and (decompos\$5 activat\$5))	US-PGPUB; USPAT	OR	ON	2006/09/15 17:57
L2	22	(118/50.1) and (heat\$3 with (element filament) with (decompos\$5 activat\$5))	US-PGPUB; USPAT	OR	ON	2006/09/15 17:57
L3	0	("6965093").URPN.	USPAT	OR	ON	2006/09/15 17:54
L4	6	("4698486" "5315092" "5862302" "5951896" "6081072" "6191392").PN.	US-PGPUB; USPAT; USOCR	OR	ON	2006/09/15 17:54
L5	90	("4698486").URPN.	USPAT	OR	ON	2006/09/15 17:56
L6	4	(118/50.1) and (heat\$3 with (wire) with (decompos\$5 activat\$5))	US-PGPUB; USPAT	OR	ON	2006/09/15 17:58
L7	1865	heat\$3.clm. and (element filament wire).clm. and (decompos\$5 activat\$5 catalyz\$4).clm. and (shield\$3 plate panel).clm.	US-PGPUB; USPAT	OR	ON	2006/09/15 18:00
L8	257	heat\$3.clm. and (element filament wire).clm. and (decompos\$5 activat\$5 catalyz\$4).clm. and (shield\$3 plate panel).clm. and gas.clm. and (coat\$3 deposit\$4 ((film layer) with form\$3)).clm.	US-PGPUB; USPAT	OR	ON	2006/09/15 18:01
L9	100	heat\$3.clm. and (element filament wire).clm. and (decompos\$5 activat\$5 catalyz\$4).clm. and (shield\$3 plate panel).clm. and (gas.clm. with (coat\$3 deposit\$4 ((film layer) with form\$3)).clm.)	US-PGPUB; USPAT	OR	ON	2006/09/15 18:01
L10	55	taniguchi.in. and ((hot heat\$3) with (wire element filament)) and ("cvd" (chemical adj1 vapor adj1 deposit\$3))	US-PGPUB; USPAT	OR	ON	2006/09/15 18:06
S7	2	"6593548"	US-PGPUB; USPAT	OR	ON	2005/09/02 14:35
S8	5	((("5122466") or ("6069094") or ("6432206") or ("5415753") or ("6325857")).PN.	US-PGPUB; USPAT	OR	OFF	2005/09/01 15:56
S9	2978	((219/390) or (219/409) or (219/541) or (219/405) or (219/411)).CCLS.	US-PGPUB; USPAT	OR	OFF	2006/02/21 03:10
S10	376	S9 and ("cvd" (chemical adj1 vapor adj1 deposit\$3))	US-PGPUB; USPAT	OR	ON	2005/09/02 14:55
S11	144	S10 and ((hot heat\$3) with (wire filament))	US-PGPUB; USPAT	OR	ON	2005/09/02 14:56
S12	1159	("cvd" (chemical adj1 vapor adj1 deposit\$3)) with ((hot heat\$3) with (wire filament))	US-PGPUB; USPAT	OR	ON	2005/09/01 18:27
S13	22	("cvd" (chemical adj1 vapor adj1 deposit\$3)) with ((hot heat\$3) with (wire filament)).ti.	US-PGPUB; USPAT	OR	ON	2005/09/01 16:23
S14	22	("cvd" (chemical adj1 vapor adj1 deposit\$3)).ti. with ((hot heat\$3) with (wire filament)).ti.	US-PGPUB; USPAT	OR	ON	2005/09/01 16:23
S15	381	("cvd" (chemical adj1 vapor adj1 deposit\$3)) with ((hot heat\$3) with (wire filament))	EPO; JPO; DERWENT	OR	ON	2005/09/01 16:29
S16	285	("cvd" (chemical adj1 vapor adj1 deposit\$3)) with ((hot heat\$3) near2 (wire filament))	EPO; JPO; DERWENT	OR	ON	2005/09/01 17:30
S17	2	"08115882"	EPO; JPO; DERWENT	OR	ON	2005/09/01 17:28
S18	3	"2005048273"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/01 17:28
S19	1052	("cvd" (chemical adj1 vapor adj1 deposit\$3)) with ((hot heat\$3) near2 (wire filament))	US-PGPUB; USPAT	OR	ON	2005/09/01 17:31
S20	9	("cvd" (chemical adj1 vapor adj1 deposit\$3)) with ((hot heat\$3) near2 (wire filament)) with (cover\$3 shield\$3)	US-PGPUB; USPAT	OR	ON	2005/09/01 17:33

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S21	284	((("cvd" (chemical adj1 vapor adj1 deposit\$3)) with ((hot heat\$3) near2 (element wire filament))) and (heat\$3 with (cover\$3 shield\$3)))	US-PGPUB; USPAT	OR	ON	2005/09/01 17:33
S22	92	((("cvd" (chemical adj1 vapor adj1 deposit\$3)) with ((hot heat\$3) near2 (element wire filament))) and ((wire filament) with (cover\$3 shield\$3)))	US-PGPUB; USPAT	OR	ON	2005/09/01 17:48
S23	305	((("cvd" (chemical adj1 vapor adj1 deposit\$3)) with ((hot heat\$3) near2 (element wire filament))) and ((wire filament element) with (cover\$3 shield\$3)))	US-PGPUB; USPAT	OR	ON	2005/09/01 17:49
S24	213	S23 not S22	US-PGPUB; USPAT	OR	ON	2005/09/01 17:49
S25	49	(US-20040065260-\$ or US-20020189545-\$ or US-20040069231-\$).did. or (US-6593548-\$ or US-5122466-\$ or US-5415753-\$ or US-6069094-\$ or US-6325857-\$ or US-6432206-\$ or US-4652727-\$ or US-5573690-\$ or US-5147687-\$ or US-5160544-\$ or US-6582780-\$ or US-6153061-\$ or US-6817550-\$).did. or (WO-2068709-\$ or WO-2005014886-\$).did. or (JP-02229794-\$ or JP-04280894-\$ or JP-05000890-\$ or JP-08115882-\$ or JP-2002016003-\$ or JP-2002093713-\$ or JP-2002261025-\$ or JP-2003342736-\$ or JP-2004027326-\$ or JP-2004035981-\$ or JP-2004091821-\$ or JP-2005048273-\$).did. or (US-5124179-\$ or US-5126206-\$ or US-5147687-\$ or US-5160544-\$ or US-5186973-\$ or JP-05283344-\$ or JP-08115882-\$ or US-6161499-\$ or JP-2002093713-\$ or JP-2002093714-\$ or US-6427622-\$ or US-6432206-\$ or KR-2003047574-\$ or US-6582780-\$ or JP-2003342736-\$ or JP-2004027326-\$ or JP-2004035981-\$ or JP-2004150541-\$ or JP-2005048273-\$).did.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2005/09/01 17:49
S26	15	S25 and (tungsten molybdenum)	US-PGPUB; USPAT	OR	ON	2005/09/01 17:52
S27	151	S24 and (tungsten molybdenum tantalum rhenium)	US-PGPUB; USPAT	OR	ON	2005/09/01 18:02
S28	118	S24 and ((tungsten molybdenum tantalum rhenium) same (wire filament element))	US-PGPUB; USPAT	OR	ON	2005/09/01 18:08
S29	111	S24 and ((tungsten molybdenum tantalum rhenium) near40 (wire filament element))	US-PGPUB; USPAT	OR	ON	2005/09/01 18:02
S30	74	(118/723hc).CCLS.	US-PGPUB; USPAT	OR	OFF	2005/09/01 18:09
S31	3	("5554222").URPN.	USPAT	OR	ON	2005/09/01 18:21
S32	16	((("cvd" (chemical adj1 vapor adj1 deposit\$3)) with ((hot heat\$3) with (wire filament))) and 118/723R.ccls.	US-PGPUB; USPAT	OR	ON	2005/09/01 18:31
S33	28	((("cvd" (chemical adj1 vapor adj1 deposit\$3)) with ((hot heat\$3) with (wire filament))) and 118/724.ccls.	US-PGPUB; USPAT	OR	ON	2005/09/01 20:37
S34	126	ishibashi-keiji.in. tanaka-masahiko.in. karasawa-minoru.in. matsumura-hideki.in. masuda-atsushi.in.	US-PGPUB; USPAT	OR	ON	2005/09/01 20:38
S35	24	S34 and (wire filament)	US-PGPUB; USPAT	OR	ON	2005/09/01 20:44
S36	6	sunayama-hideki.in.	US-PGPUB; USPAT	OR	ON	2005/09/01 20:47
S37	7	("4633809" "5128515" "5383984" "5788799" "6055927" "6227140" "6673198").PN.	US-PGPUB; USPAT	OR	ON	2005/09/01 20:47
S38	13	"118"/\$.ccls. and (catalytic with crack\$3)	US-PGPUB; USPAT	OR	ON	2005/09/02 14:35
S39	593	catalytic with ("cvd" (chemical adj1 vapor adj1 deposit\$3))	US-PGPUB; USPAT	OR	ON	2005/09/02 14:55
S40	193	S39 and ((hot heat\$3) with (wire element filament))	US-PGPUB; USPAT	OR	ON	2005/09/02 15:00

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S41	347	taniguchi.in. and ((hot heat\$3) with (wire element filament))	US-PGPUB; USPAT	OR	ON	2005/09/02 15:01
S42	5	taniguchi.in. and ((hot heat\$3) with (wire element filament) with ("cvd" (chemical adj1 vapor adj1 deposit\$3)))	US-PGPUB; USPAT	OR	ON	2005/09/02 15:09
S44	5	taniguchi.in. and (((hot heat\$3) with (wire element filament)) with ("cvd" (chemical adj1 vapor adj1 deposit\$3)))	US-PGPUB; USPAT	OR	ON	2005/09/02 15:03
S45	3	taniguchi.in. and (((hot heat\$3) with (wire element filament)) with ("cvd" (chemical adj1 vapor adj1 deposit\$3)))	EPO; JPO; DERWENT	OR	ON	2005/09/02 15:05
S46	29	hitachi.as. and (((hot heat\$3) with (wire element filament)) with ("cvd" (chemical adj1 vapor adj1 deposit\$3)))	EPO; JPO; DERWENT	OR	ON	2005/09/02 15:05
S47	26	hitachi.as. and ((hot heat\$3) with (wire element filament) with ("cvd" (chemical adj1 vapor adj1 deposit\$3)))	US-PGPUB; USPAT	OR	ON	2005/09/02 15:09
S48	4	("3926842" "4812201" "5723371" "6305390").PN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/09/02 15:39
S49	3	"2002067445"	EPO; JPO; DERWENT	OR	ON	2005/09/02 15:39
S50	1	"200267445"	EPO; JPO; DERWENT	OR	ON	2005/09/02 15:40
S51	0	"2002-67445"	EPO; JPO; DERWENT	OR	ON	2005/09/02 15:40
S52	0	"niira-koichiro.in"	EPO; JPO; DERWENT	OR	ON	2005/09/02 15:41
S53	0	niira-koichiro.in.	EPO; JPO; DERWENT	OR	ON	2005/09/02 15:41
S54	0	niira-koichiro-\$.in.	EPO; JPO; DERWENT	OR	ON	2005/09/02 15:41
S55	0	senta-hirofumi-\$.in.	EPO; JPO; DERWENT	OR	ON	2005/09/02 15:41
S56	0	hakuma-hideki.in.	EPO; JPO; DERWENT	OR	ON	2005/09/02 15:41
S57	0	hakuma-hideki-\$.in.	EPO; JPO; DERWENT	OR	ON	2005/09/02 15:53
S58	6	("20020036724" "5646424" "5962897" "6066547" "6225197" "6342409").PN.	US-PGPUB; USPAT	OR	ON	2005/09/02 15:57
S59	0	arichika-ishida.in.	US-PGPUB; USPAT	OR	ON	2005/09/02 15:57
S60	0	arichika-ishida.in.	EPO; JPO; DERWENT	OR	ON	2005/09/02 15:57
S61	41	ishida-arichika.in.	EPO; JPO; DERWENT	OR	ON	2005/09/02 15:58
S62	4	ishida-arichika.in. and (thin with film with formation)	EPO; JPO; DERWENT	OR	ON	2005/09/02 15:59
S63	3	"200114256"	EPO; JPO; DERWENT	OR	ON	2005/09/02 16:00
S64	2	"2000114256"	EPO; JPO; DERWENT	OR	ON	2005/09/02 16:00
S65	592	heat\$3.clm. and element.clm. and "CVD".clm. "chemical vapor deposition".clm. and "power.clm"	US-PGPUB; USPAT	OR	ON	2006/02/21 03:04
S66	28090	heat\$3.clm. and element.clm. and "CVD".clm. "chemical vapor deposition".clm. and "power.clm" (decompos\$5 activ5).clm.	US-PGPUB; USPAT	OR	ON	2006/02/21 03:04
S67	592	heat\$3.clm. and element.clm. and "CVD".clm. "chemical vapor deposition".clm. and "power.clm" and (decompos\$5 activ5).clm.	US-PGPUB; USPAT	OR	ON	2006/02/21 03:04

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S68	592	heat\$3.clm. and element.clm. and "CVD".clm. "chemical vapor deposition".clm. and "power.clm" and (decompos\$5 activ\$5).clm.	US-PGPUB; USPAT	OR	ON	2006/02/21 03:05
S69	808	heat\$3.clm. and element.clm. and "CVD".clm. "chemical vapor deposition".clm. and power.clm. and (decompos\$5 activ\$5).clm.	US-PGPUB; USPAT	OR	ON	2006/02/21 03:05
S70	27	heat\$3.clm. and element.clm. and ("CVD".clm. "chemical vapor deposition".clm.) and power.clm. and (decompos\$5 activ\$5).clm. and (gas vapor).clm.	US-PGPUB; USPAT	OR	ON	2006/02/21 03:06
S71	1427	(118/724).CCLS.	US-PGPUB; USPAT	OR	OFF	2006/02/21 03:11
S72	249	S71 and (heat\$3 with (element filament) and (decompos\$5 activat\$5))	US-PGPUB; USPAT	OR	ON	2006/09/15 17:45
S73	50	S71 and (heat\$3 with (element filament) with (decompos\$5 activat\$5))	US-PGPUB; USPAT	OR	ON	2006/02/21 03:11
S74	21	"0225712"	EPO; JPO; DERWENT	OR	ON	2006/02/24 13:08
S75	2	"200225712"	EPO; JPO; DERWENT	OR	ON	2006/02/24 13:08
S76	0	("6709512").URPN.	USPAT	OR	ON	2006/02/24 19:36
S77	1	("5840631").PN.	US-PGPUB; USPAT; USOCR	OR	ON	2006/02/24 19:36